

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known		
			Application Number	10/730230	
			Filing Date		
			First Named Inventor	Bishnu P. Gogoi et al.	
			Group Art Unit	2823	
			Examiner Name	Michelle Estrada	
Sheet	1	of	1	Attorney Docket Number	SC12116ZP

U. S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)				
ME	AA	US -6,635,509 B1		10-21-2003	OUELLET	
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FOREIGN PATENT DOCUMENTS								
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
ME	AB	BURNS et al., "Sealed-cavity Resonant Microbeam Accelerometer," SENSORS AND ACTUATORS 1 53 (1996), PP. 249-255.	
ME	AC	LIN et al, "Microelectromechanical Filters for Signal Processing," IEEE JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, VOL. 7, NO. 3, SEPTEMBER 1998, pp. 286-294.	
ME	AD	GOGOI et al., "A Low-Voltage Force-Balanced Pressure Sensor With Hermetically Sealed Servomechanism," IEEE 1999, pp. 493-498.	
ME	AE	Application number 10/328,923 filed 12/23/02.	
ME	AF	Application number 10/328,922 filed 12/23/02.	

Examiner Signature	Michelle Estrada	Date Considered	12/8/05
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¹ Unique citation designation number. ² See Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English Language Translation is attached.

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